



Substitute for form 1449A/PTO			Complete if Known		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)			Application Number	10/713,219	
			Filing Date	November 17, 2003	
			First Named Inventor	Shinji MAEKAWA et al.	
			Art Unit	2813	
			Examiner Name	Laura M. Schillinger	
Sheet	1	of	1	Attorney Docket Number	740756-2670

U.S. PATENT DOCUMENTS					
Examiner Initials [*]	Cite No. ¹	U.S. Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
XZu	1	US-2002/0098628 A1	07/25/2002	Hamada et al.	
	2	US-2002/0125480 A1	09/12/2002	Nakamura et al.	
	3	US-2002/0182783 A1	12/05/2002	Takayama et al.	
	4	US-2004/0121530 A1	06/24/2004	Yamazaki et al.	
	5	US-2004/0224486 A1	11/11/2004	Ichijo et al.	
	6	US-2005/0009257 A1	01/13/2005	Yamazaki et al.	
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Examiner Initials [*]	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁴
		Country Code ³ Number ⁴ Kind Code ² (if known)				
XZu	14	JP-08-078329	03/22/1996	OHTANI		ABS
	15	EP-0 651 431 A2	05/03/1995	OHTANI et al.		FULL

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS		
Examiner Initials [*]	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
XZu	16	U.S. Patent Application Serial No. 08/784,293, Yamazaki et al., filed: January 16, 1997, entitled: "Fabrication Method of Semiconductor Device," including the filing receipt, specification, claims, drawings, and the allowed claims as of November 8, 2005.

Examiner Signature	<i>Laura M. Schillinger</i>	Date Considered	7/7/06
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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